



Docket No.: H0498.70130US01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Tao Deng
Serial No.: 10/763,819
Confirmation No.: 5026
Filed: January 23, 2004
For: FABRICATION OF METALLIC MICROSTRUCTURES VIA
EXPOSURE OF PHOTSENSITIVE COMPOSITION
Examiner: K. Duda
Art Unit: 1756

Certificate of Mailing Under 37 CFR 1.8(a)

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as First Class Mail, in an envelope addressed to: Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Dated: 4/11/07

Melanie Chew Sand
Signature

TRANSMITTAL LETTER

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

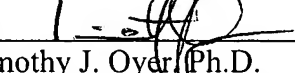
Enclosed are the following items for filing in connection with the above-referenced
Patent Application:

1. Amendment After Allowance;
2. Part B - Issue Fee Transmittal; and
3. Return Receipt Postcard.

Our check in the amount of \$1,000.00 covering the required fees. is enclosed. The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 23/2825, under Docket No. H0498.70130US01. A duplicate copy of this paper is enclosed.

Dated: April 11, 2007

Respectfully submitted,

By 
Timothy J. Oyer (Ph.D.)
Registration No.: 36,628
WOLF, GREENFIELD & SACKS, P.C.
Federal Reserve Plaza
600 Atlantic Avenue
Boston, Massachusetts 02210-2206
(617) 646-8000